



#11/256-03
Attorney's Docket No.: 4563-3/450001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Fritz Redeker et al. Art Unit : 2812
Serial No. : 09/918,591 Examiner : Angel Roman
Filed : July 27, 2001
Title : CHEMICAL MECHANICAL POLISHING OF A METAL LAYER WITH
POLISHING RATE MONITORING

Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Applicant submits copies of the references listed on the attached form PTO-1449.

This filing is being made with the filing of a Request for Continued Examination. No fee is required.

Respectfully submitted,

Date: 1/9/03

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I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

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